

Ok to enter

AF/IFW



OK 1/17/06

Attorney Docket 0553-0393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Shunpei Yamazaki et al.)
)
Serial No.: 10/757,167)
)
Filed: January 13, 2004)
)
For: Method For Manufacturing Conductive)
Layer And Semiconductor Device)
)
Art Unit: 2822)
)
Examiner: Christy L. Novacek)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited
with the United States Postal Service as first class mail in an
envelope addressed to:

Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on

January 4, 2006

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace

Signature

1/4/06

Date

AMENDMENT (B) AFTER FINAL

Sir:

In response to the Final Rejection of October 5, 2005, please enter the following amendment
in the above-identified application: